

Docket No.: 203424US0XPCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: : ATTN: PCT Legal Office
Pascal MOTTE et al. : INT'L. APPLICATION
: PCT/FR00/01891
SERIAL NUMBER: 09/786,059 :
INT'L. FILING DATE: 03 July 2000 :
FOR: METHOD FOR DEPOSITING A SILICON-CONTAINING DIELECTRIC
MATERIAL ON COPPER

**PETITION UNDER 37 C.F.R. 1.181 TO WITHDRAW
HOLDING OF ABANDONMENT**

ASST. COMMISSIONER OF PATENTS & TRADEMARKS
WASHINGTON, D.C. 20231

SIR:

Applicants are in receipt of a notice of abandonment mailed April 29, 2002 in the above-identified national stage application which states that the application is abandoned for failure to respond to the notification of Missing Requirements in a timely manner.

However, Applicants did respond to the notification of Missing Requirements in a timely manner on June 13, 2001 by filing an executed Declaration. A copy of Applicants' response, a copy of the executed Declaration, and a copy of the undersigned's date-stamped filing receipt is attached hereto.

Applicants' therefore believe that sufficient evidence has been presented for the Patent Office to withdraw the holding of abandonment. Such action is hereby earnestly solicited.

The required petition fee of \$130.00 is being submitted herewith. If any variance exists between the amount enclosed and the Patent Office charges, please charge or credit the

05/10/2002 SNAJARRO 00000083 09786059

01 FC:122

130.00 0P

difference to our Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND
MAIER & NEUSTADT, P.C.



Norman F. Oblon
Registration No. 24,618
Surinder Sachar
Registration No. 34,423
Attorneys of Record



22850